

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Yuichiro MATSUO, et al.

Serial Number: Not Yet Assigned

Filed: November 19, 2003

Customer No.: 38834

For: NEGATIVE ION GENERATING MEDIUM AND ITS MANUFACTURING METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

November 19, 2003

Sir:

In compliance with 37 CFR 1.56, Applicant(s) call(s) to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449.

Copies of each of the references are enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,
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Enclosures: PTO-1449; References(4)

**INFORMATION
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Applicant(s): Yuichiro MATSUO, et al.

Filing Date: November 19, 2003 Group Art Unit:

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
	AA					
	AB					
	AC					
	AD					

FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Translation (Yes or No)
	AE	1207220A1	05/22/2002	Europe	
	AF	2001-161414	06/19/2001	Japan	Abstract. Discussed in the spec.
	AG	2001-295105	10/26/2001	Japan	Abstract. Discussed in the spec.
	AH	2001-288679	10/19/2001	Japan	Abstract. Discussed in the spec.
	AI				

OTHER DOCUMENTS

	AJ	
	AK	
Examiner		Date Considered